

Search Notes 	Application/Control No. 10/053,785	Applicant(s)/Patent under Reexamination CHEN ET AL.
	Examiner Robert R. Koehler	Art Unit 1775

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
205	224, 227	4/18/2005	RRK.
205	255		
148	108, 121		
148/518, 529		4/18/2005	RRK.